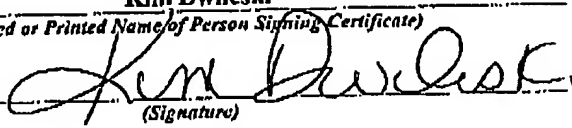


CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)			Docket No. RJR920040018US1
Applicant(s): Chapple-Sokol et al.			
Application No. 10/708,486	Filing Date 3/6/2004	Examiner Gebremariam, Samuel A.	Group Art Unit 2811
Invention: SUPPRESSION OF LOCALIZED METAL PRECIPITATE FORMATION AND CORRESPONDING METALLIZATION DEPLETION IN SEMICONDUCTOR PROCESSING			
RECEIVED CENTRAL FAX CENTER NOV 04 2005			
I hereby certify that this <u>Restriction Election (2 pages)</u> (Identify type of correspondence) is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>571-273-8300</u>) on <u>11/4/2005</u> (Date)			
<u>Kim Dwileski</u> (Typed or Printed Name of Person Signing Certificate)  (Signature)			
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DOCKET NO.: BUR920040018US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Chapple-Sokol *et al.*

Examiner: Gebremariam, Samuel A.

Serial No.: 10/708,486

Art Unit: 2811

Filed: 3/6/2004

For: **SUPPRESSION OF LOCALIZED METAL PRECIPITATE FORMATION AND
CORRESPONDING METALLIZATION DEPLETION IN SEMICONDUCTOR
PROCESSING**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

RESTRICTION ELECTION

In response to the Restriction Requirement dated October 6, 2005, Applicants hereby provisionally elect Group 1, claims 1-10 and 21-25, drawn to a semiconductor integrated circuit device, classified in Class 257, subclass 13. This election is made with traverse, and Applicants hereby reserve the right to file a divisional application in connection with unelected claims 11-20 and 26-35, drawn to a method of forming integrated circuit device.

With regard to the Restriction Requirement, Applicants respectfully submit that the subject matter of all claims 1-35 is sufficiently related that a thorough search for the subject matter of any one group of claims would encompass a search for the subject matter of the remaining claims. Thus, Applicants respectfully submit that the search and the examination of the entire application could be made without serious burden. See MPEP § 803, in which it is stated that "if the search and examination of the entire application can be made without serious burden,

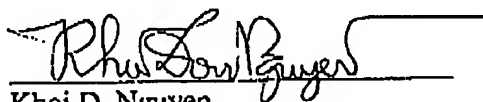
10/708,486

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the Examiner must examine it on the merits." Applicants respectfully submit that this policy should apply in the present application in order to avoid unnecessary delay and expense to Applicants and duplicative examination by the Patent Office.

Should the Examiner require or request anything further from Applicants prior to examination, the Examiner is requested to contact Applicants' undersigned representative at the telephone number below. Otherwise, Applicants request early and favorable examination on the merits. The Director is hereby authorized to charge and/or credit Deposit Account No. 09-0456.

Date: November 04, 2005


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